



PATENT
Customer No. 22,852
Attorney Docket No. 07553.0019-01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Chishio KOSHIMIZU et al.

Application No.: 10/675,966

Filed: October 2, 2003

For: PLASMA PROCESSING
APPARATUS AND PLASMA
PROCESSING METHOD

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Siri:

AMENDMENT

In reply to the Office Action mailed February 8, 2007, the period for response having been extended through August 8, 2007 by a petition for extension of time of three months and fee payment filed concurrently herewith, please amend the application as follows:

Amendments to the Claims are reflected in the listing of claims in this paper.

Remarks follow the amendment section of this paper.